

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
:
: Confirmation No. 4540
Sun Jin YUN et al. :
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U.S. Patent Application No. 10/777,102 : Group Art Unit: 2815
:
Filed: February 13, 2004 : Examiner: DIAZ, JOSE R

For: Substrate with microstructure formed thereon and manufacturing method thereof

AMENDMENT

MAIL STOP AMENDMENT
COMMISSIONER FOR PATENTS
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Sir:

The following amendments and remarks are submitted in response to the Official
Action dated *January 12, 2007*.